

TJK/190/L.W.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Byoung-Youp KIM et al. ) METHOD OF FORMING A MOCVD-TIN  
Korean Patent Appln. No. 2000-46691 ) THIN FILM  
Korean Filing Date: August 11, 2000 )

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Please amend the subject application as follows:


In the Specification

**--CROSS REFERENCE TO RELATED APPLICATION**

This application claims the priority of Korean patent application Serial No. 2000-46691  
filed on August 11, 2000.-

Respectfully submitted,

Date: 8/8/01  
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